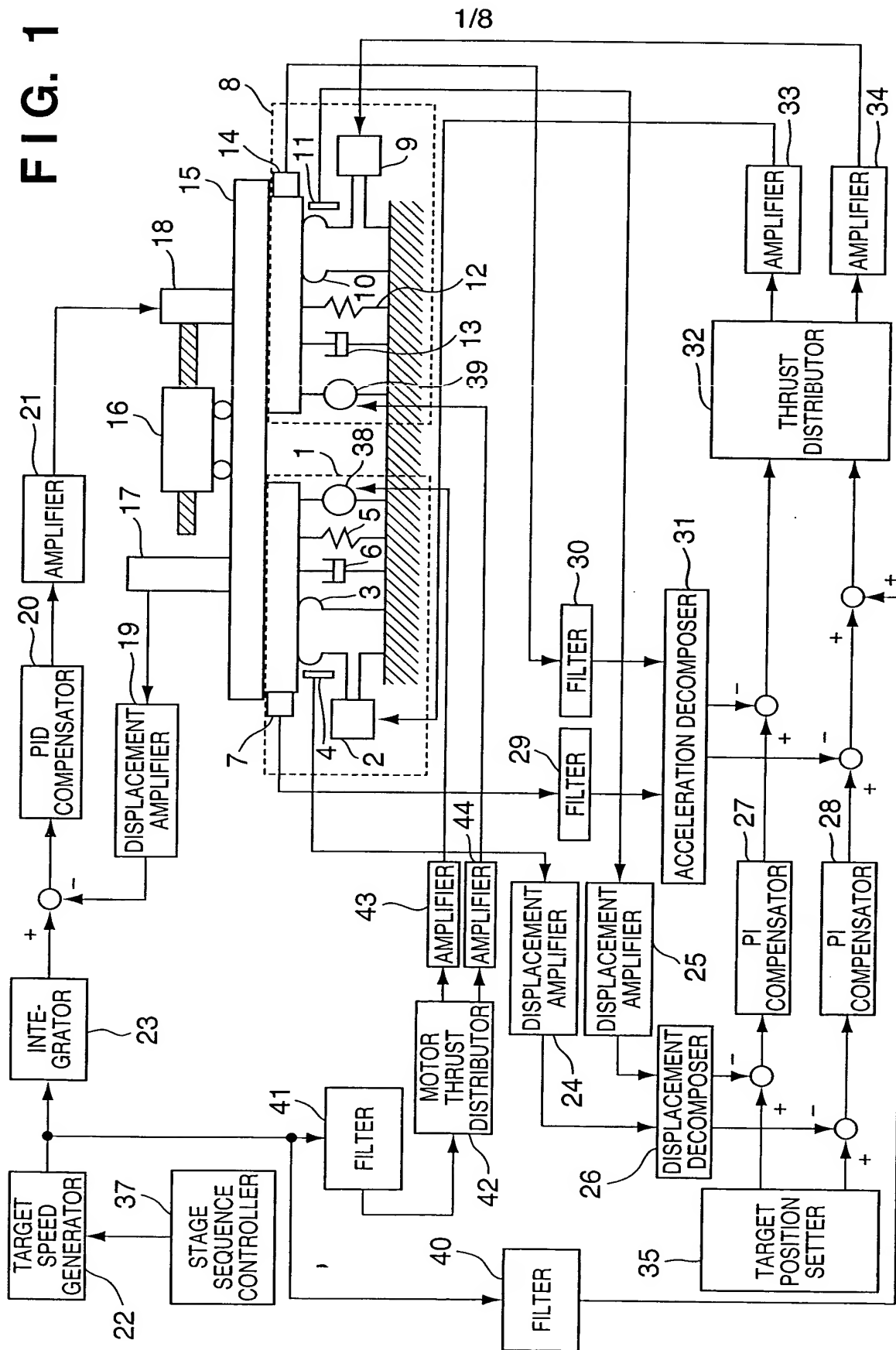
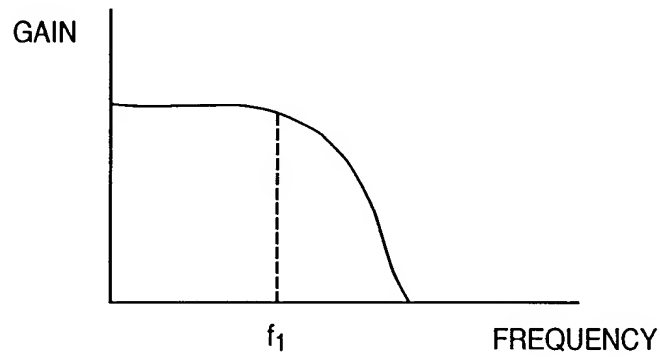


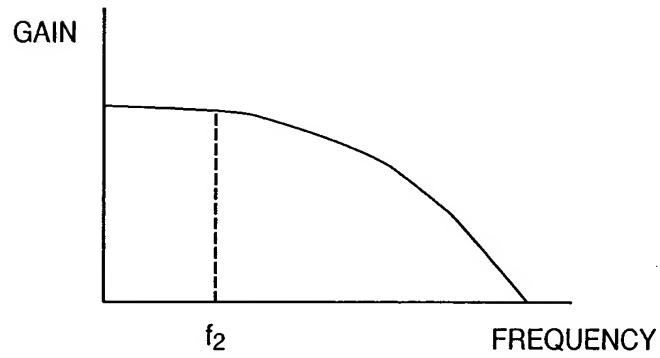
FIG. 1



**FIG. 2**



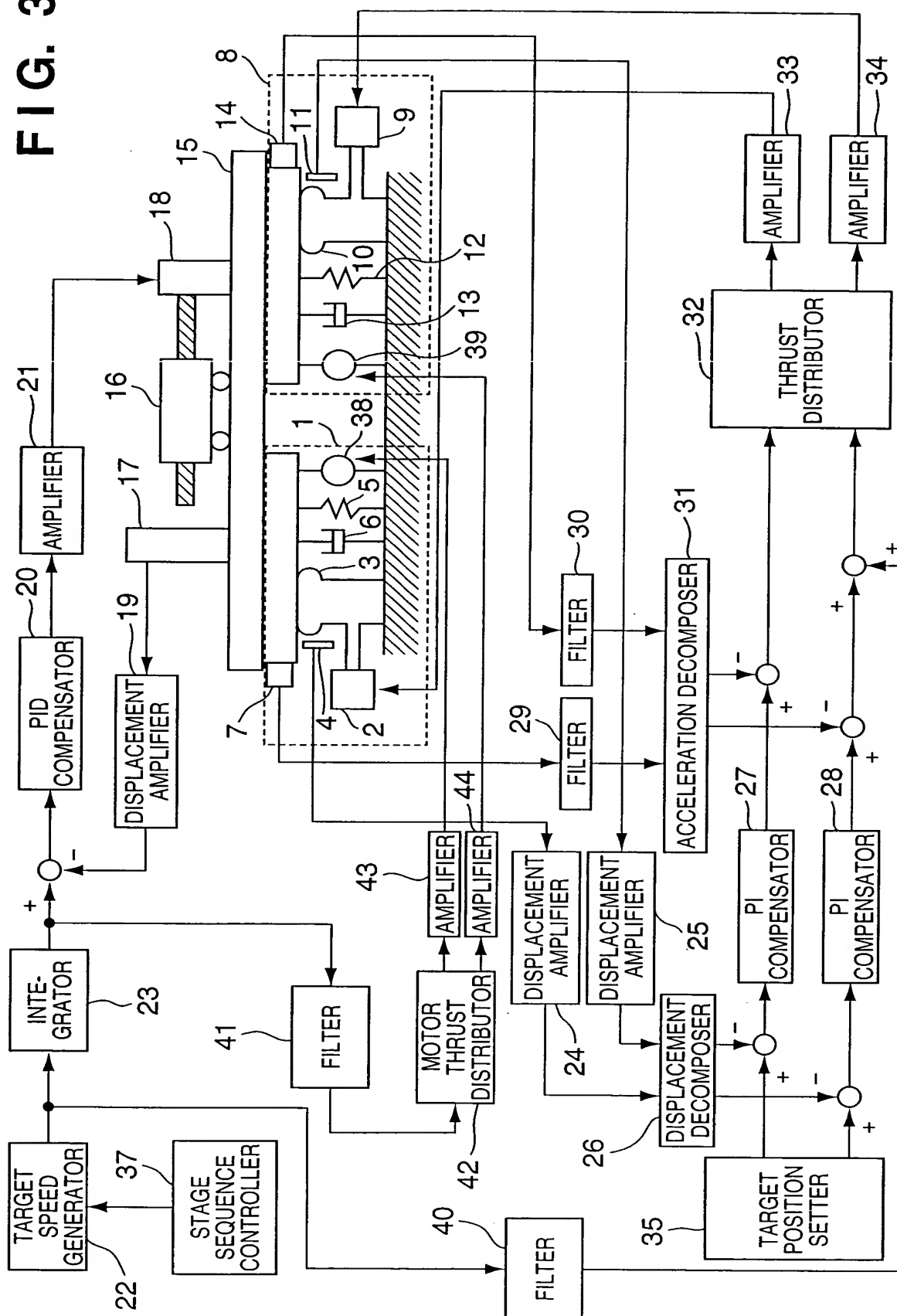
FREQUENCY CHARACTERISTICS OF FILTER 40



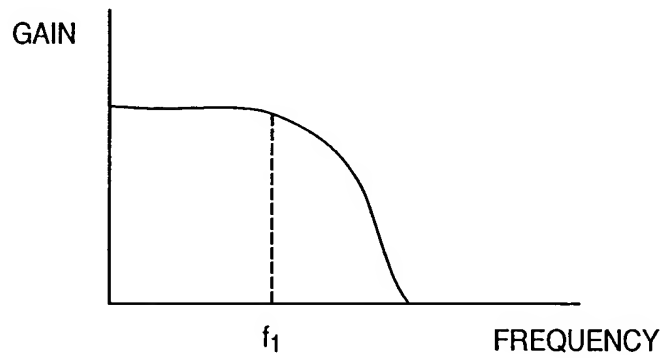
FREQUENCY CHARACTERISTICS OF FILTER 41

10073976.021402  
201120 9/6E/007

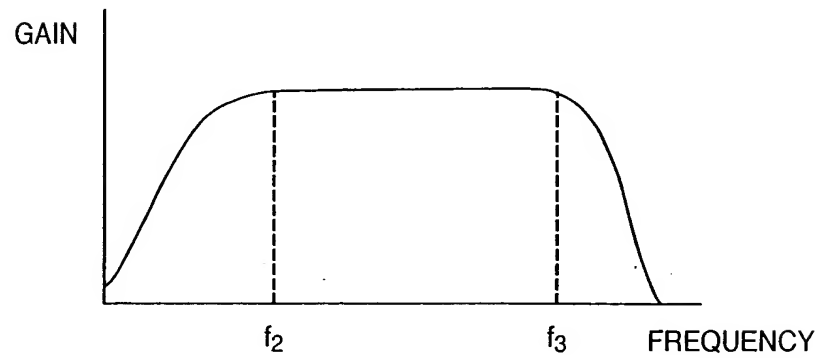
3/8



**FIG. 4**



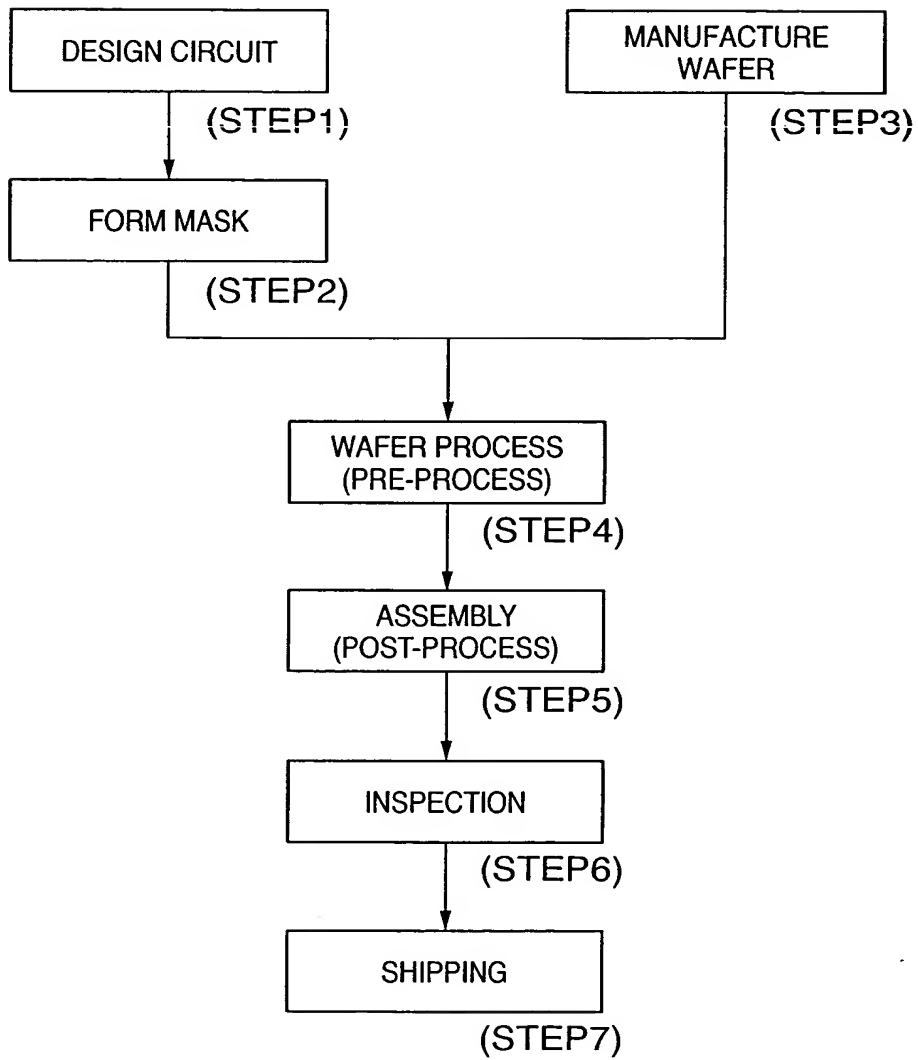
FREQUENCY CHARACTERISTICS OF FILTER 40



FREQUENCY CHARACTERISTICS OF FILTER 41

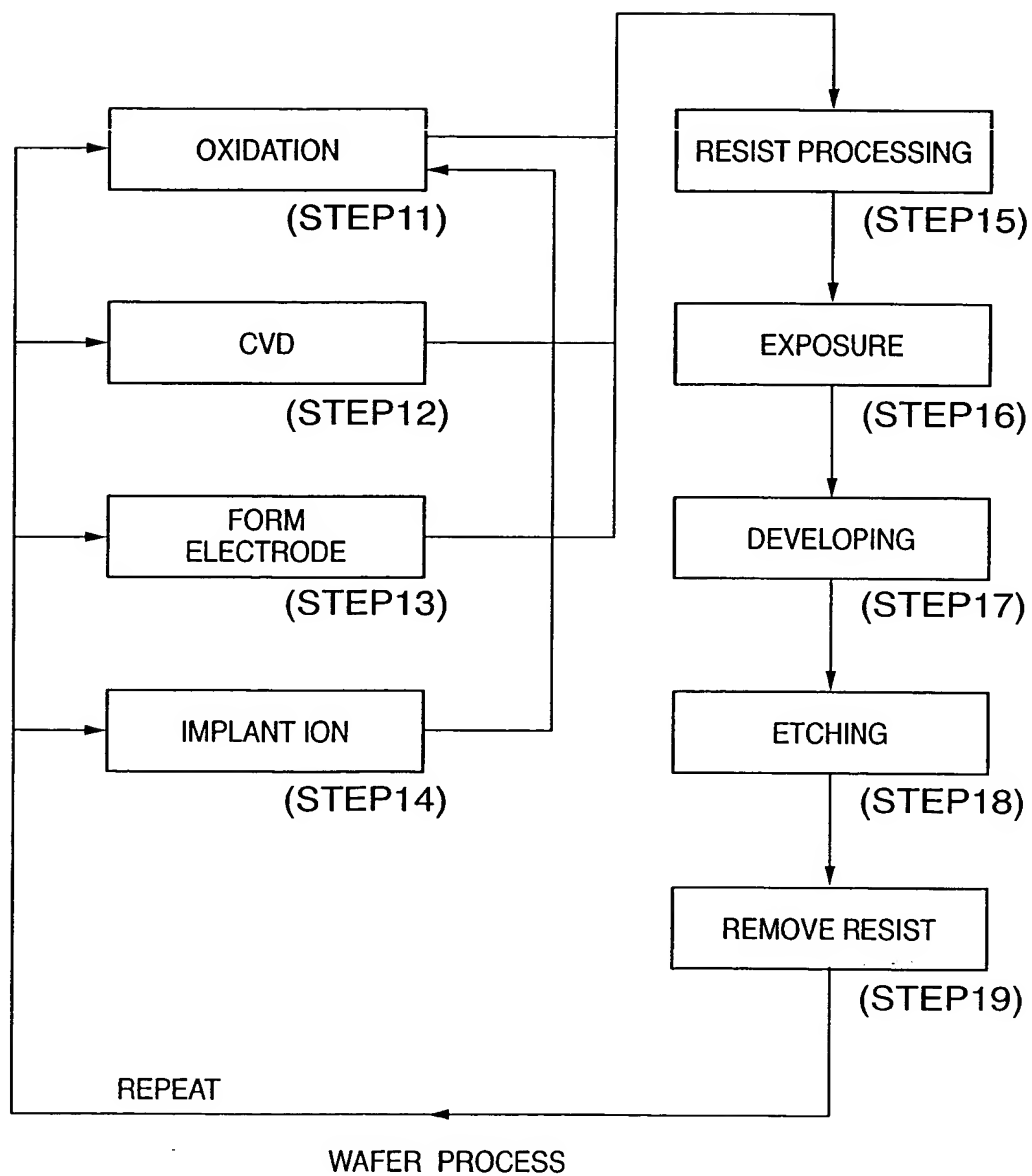
201720-9/65/001

FIG. 5



SEMICONDUCTOR DEVICE MANUFACTURING FLOW

FIG. 6



7/8

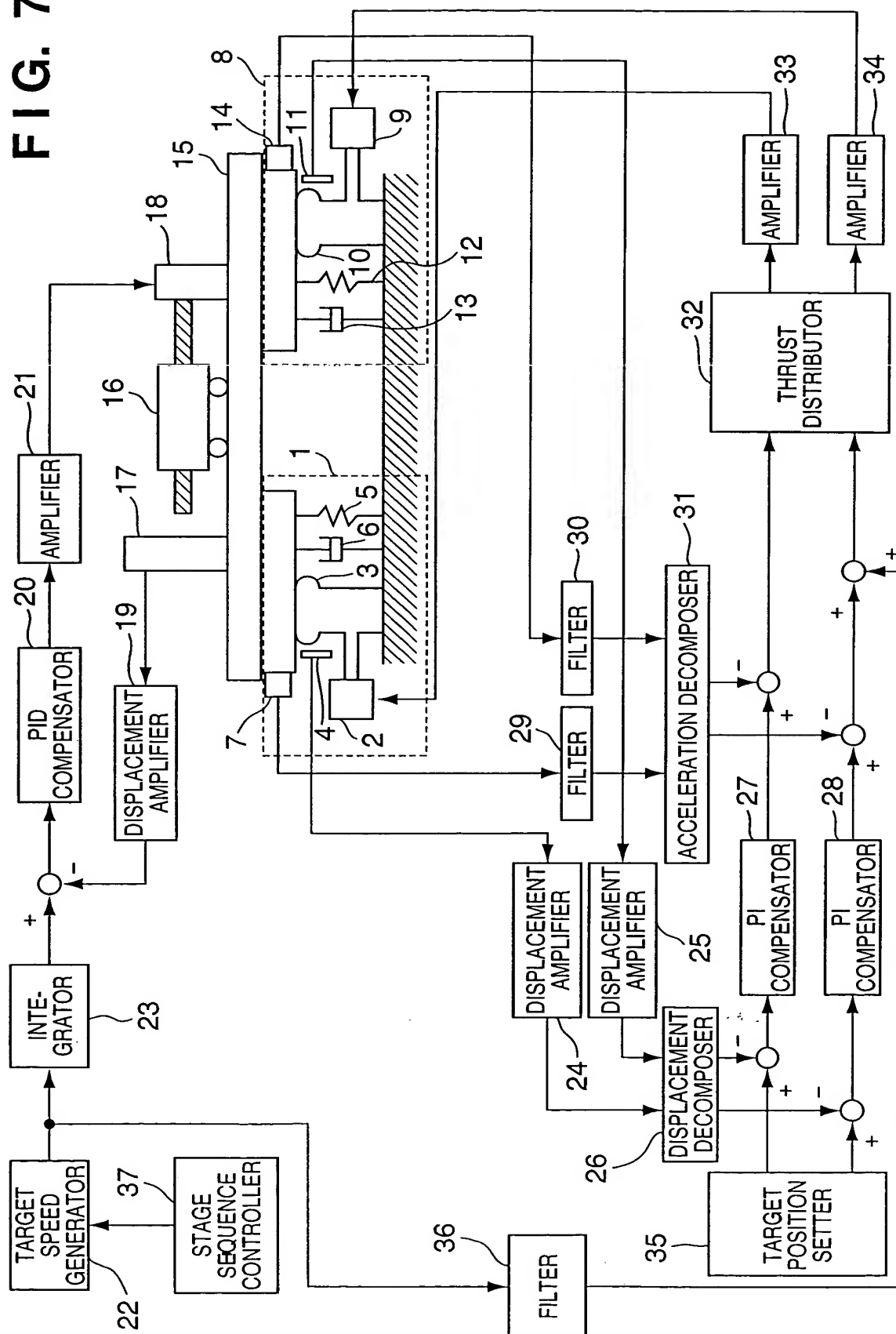
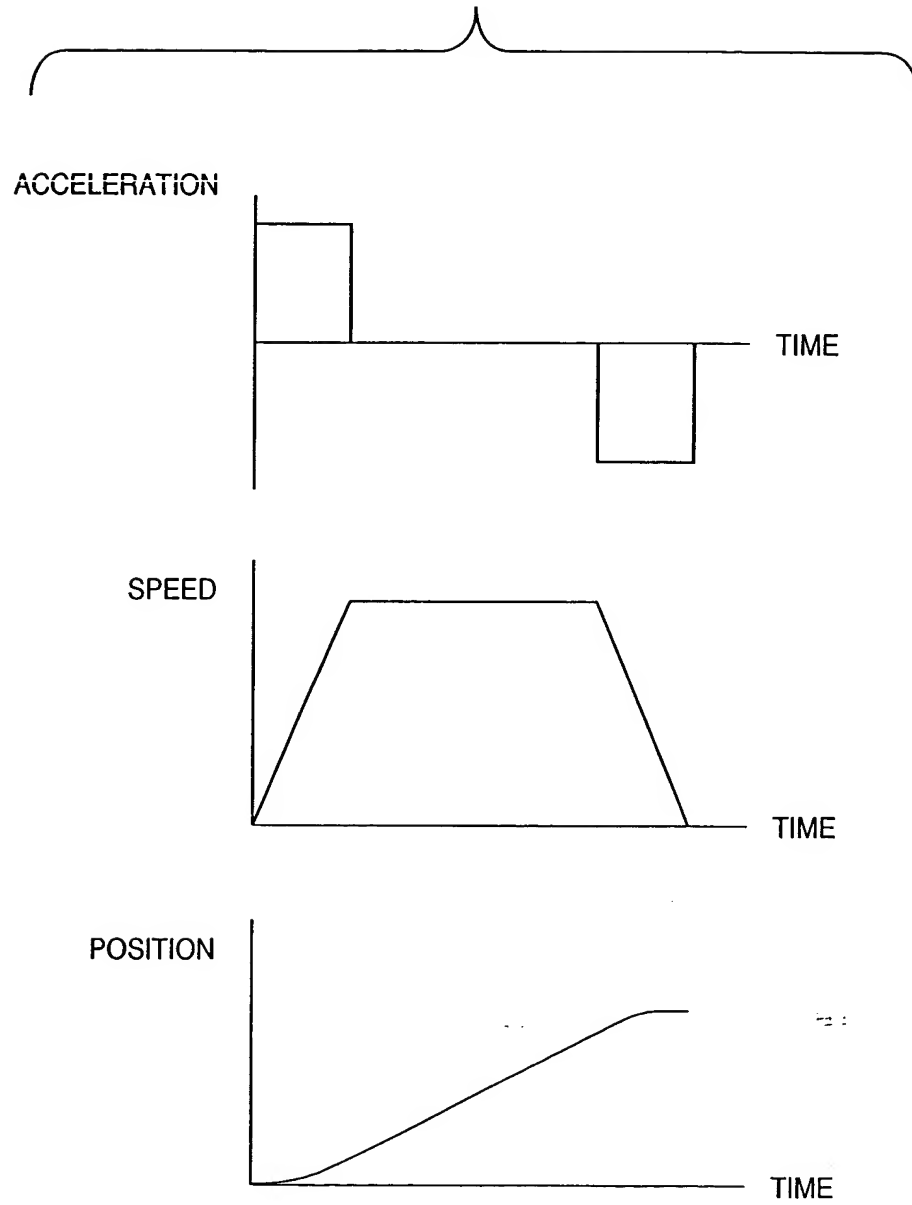


FIG. 8



10073976-024492